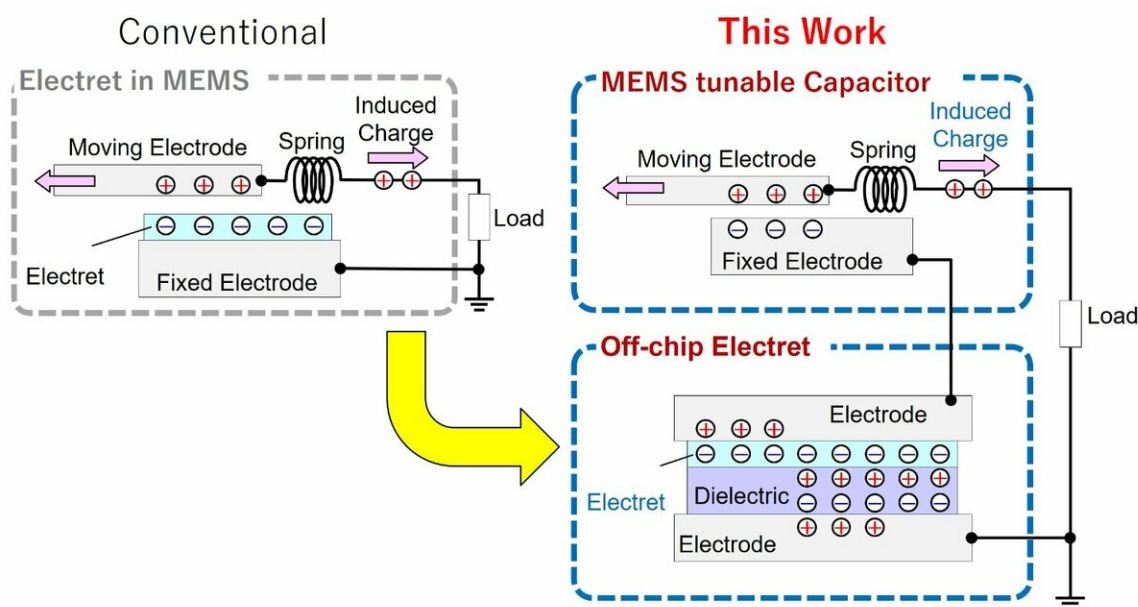


Putting free energy to good use with minuscule energy harvesters

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MEMS Vibratory Electret Energy Harvester



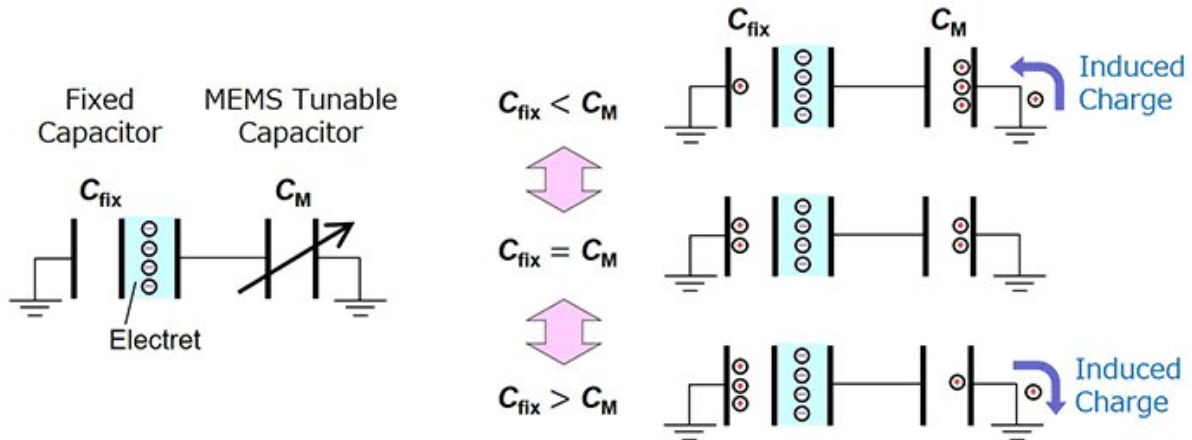
Unlike conventional electret-based MEMS energy harvesters, which contain the entire system in a single chip, the proposed design methodology involves having the electret and the MEMS tunable capacitor in different chips, loosening up design constraints. Credit: Daisuke Yamane

Scientists at Tokyo Institute of Technology (Tokyo Tech) have

developed a micro-electromechanical energy harvester that allows for more flexibility in design, which is crucial for future IoT applications.

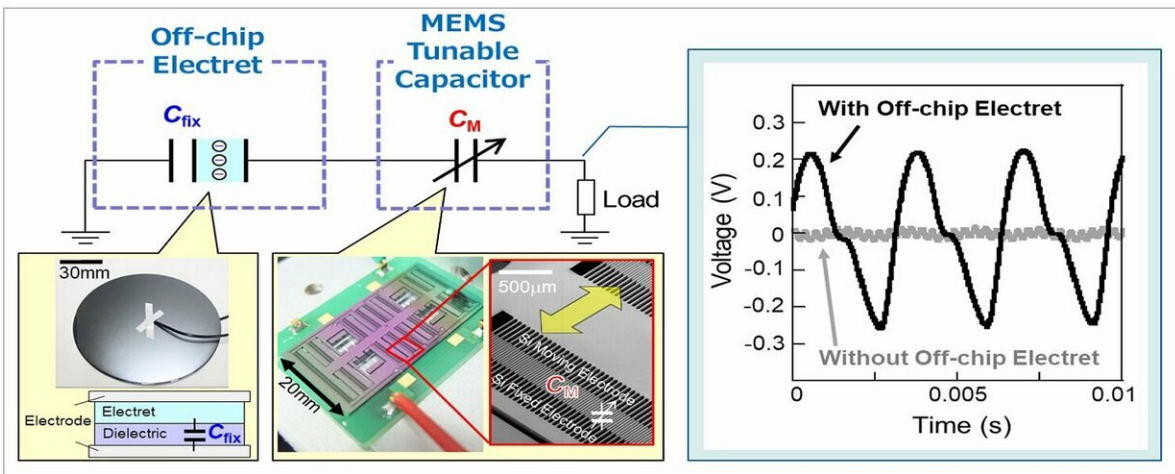
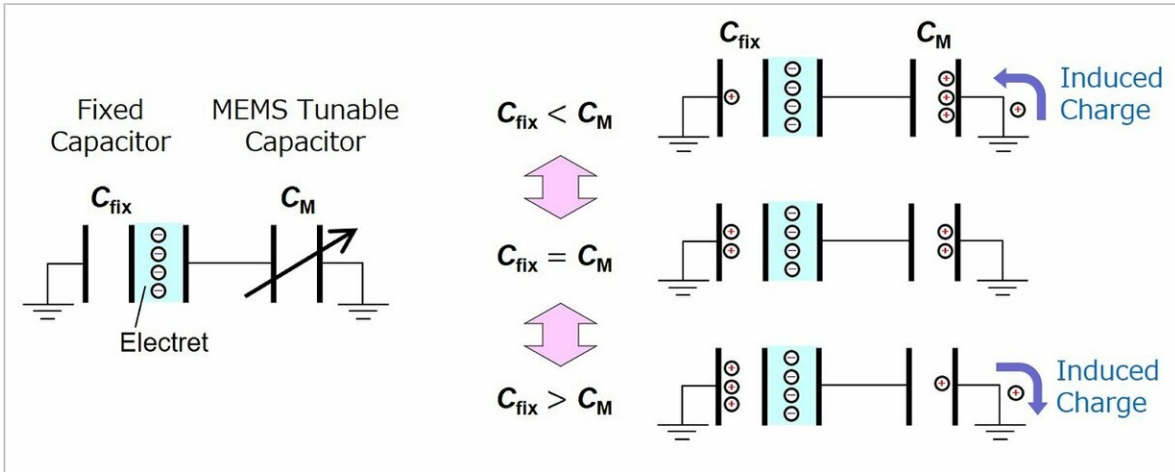
Nowadays, it would be hard to not notice that [electronic devices](#) have become incredibly small. The use of miniature sensors in the upcoming Internet of Things (IoT) era could enable us to develop applications that have only been seen in science fiction. However, microelectronic devices still require power to run, and energy-harvesting micro-electromechanical systems (MEMS) can be used so that these minuscule contraptions can run on ambient energy, such as that coming from mechanical vibrations.

As depicted in Fig. 1, conventional MEMS energy harvesters use an electret (the electrical equivalent of a permanent magnet; it has permanent charge stored in it) placed in a MEMS tunable [capacitor](#), which has a moving electrode that is pushed by ambient forces, inducing the movement of charges. Unfortunately, this design is very constrained because the fabrication processes for both the electret and the MEMS components have to be compatible. Therefore, a team of scientists, including Assistant Professor Daisuke Yamane from Tokyo Tech, proposed a new MEMS electret-based energy harvester that consists of two separate chips: one for the MEMS tunable capacitor, and one containing an electret and dielectric material to form another capacitor (Fig. 1). "This allows us to physically separate MEMS structures and electrets for the first time," states Yamane.



Principle of operation of the proposed energy harvester When the capacity of the tunable capacitor is higher than that of the electret circuit, a movement of charges is induced in one direction. Likewise, when the situation is reversed, a movement of charges is induced in the opposite direction. Credit: Tokyo Institute of Technology

The energy-harvesting mechanism of the device is shown in Fig. 2. The capacitance of the electret circuit is fixed (C_{fix}), whereas that of the MEMS tunable capacitor (C_M) changes according to the stretching of the spring (caused by external vibrations). When C_M becomes higher than C_{fix} , a movement of charges is induced and the tunable capacitor gains charge. Likewise, when C_{fix} is higher, charges move in the opposite direction and the capacitor in the electret circuit gains charge.



When the capacity of the tunable capacitor is higher than that of the electret circuit, a movement of charges is induced in one direction. Likewise, when the situation is reversed, a movement of charges is induced in the opposite direction (Above). Pictures of the system and measured voltage output. To the left, pictures of the designed system are shown; the comb-like structure of the MEMS tunable capacitor can be appreciated. To the right, the measured voltage output demonstrates that mechanical vibratory energy can be effectively harvested (Below). Credit: Daisuke Yamane

These movements of charges represent electrical power that can be exploited. The left side of Fig. 3 shows pictures of the fabricated chips

and a simplified diagram, and the right side shows that voltage can be effectively generated. "The proposed method can be a promising way to enhance the design and fabrication flexibility of both MEMS structures and electrets," concludes Yamane. Loosening up design constraints expands the limits for engineers and will accelerate the onset of the IoT era so that we can reap its benefits.

More information: A MEMS Vibratory Energy Harvester Charged by an Off-chip Electret, Conference : MEMS 2019 (The 32nd International Conference on Micro Electro Mechanical Systems)

Provided by Tokyo Institute of Technology

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